



Dkt. 71745 CCD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Todd F. BISCHOFF et al.
Serial No. : 10/735,057
Filed : December 11, 2003
For : METHOD FOR SUPPRESSING REACTION OF MOLTEN
METALS WITH REFRACTORY MATERIALS

PRELIMINARY AMENDMENT

1185 Avenue of the Americas
New York, N.Y. 10036
May 19, 2004

Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450

S I R:

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.